



Image 1731  
52201-0605

**IN THE UNITED STATES AND PATENT AND TRADEMARK OFFICE**

Applicant : Tatsuhiro Sato et al.  
Serial No. : 09/935,334  
Filed : August 22, 2001  
For : QUARTZ GLASS BODY HAVING IMPROVED  
RESISTANCE AGAINST PLASMA CORROSION,  
AND METHOD FOR PRODUCTION THEREOF  
Group art unit : 1731  
Examiner : Carlos N. Lopez

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail  
in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on: October 22, 2003

Andrew L. Tiajloff  
Name of Applicant, Assignee  
or Registered Representative

*Andrew L. Tiajloff*  
Signature

October 22, 2003  
Date of Signature

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE AND AMENDMENT**

Sir:

Applicant responds as follows to the restriction requirement dated September 24, 2003 in  
the above application.

**Election**

Applicant elects Group I, claims 1 to 15.

**Amendment**

Please amend the application as follows: